

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re application of:** Doerr et al.

**Application No.** 10/801,481

**Filed:** March 15, 2004

**FILED VIA EFS ON NOVEMBER 24, 2008**

**Confirmation No.** 1207

**For:** LINEAR OPTICAL SAMPLING  
METHODS AND APPARATUS

**Examiner:** Wai Lun Leung

**Art Unit:** 2613

**Attorney Reference No.** 1505-67922-01

COMMISSIONER FOR PATENTS

**SUPPLEMENTAL RESPONSE TO RESTRICTION REQUIREMENT**

This response supplements the Response to Restriction Requirement filed by Applicants on November 10, 2008. Please amend the referenced application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2.

**Remarks** begin on page 7.